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			APPLICANT Osamu KUSUMOTO, et al.				
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U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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FOREIGN PATENT DOCUMENTS						Translation	
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number & Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Yes	No
<i>SPK</i>		JP 11-297712	10/29/1999	SANYO ELECTRIC CO LTD		(Japan w/English Abstract)	
<i>SPK</i>		JP P2002-93742A	03/29/2002	NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL & TECHNOLOGY NISSAN MOTOR CO LTD		(Japan w/English Abstract)	
<i>SPK</i>		JP 10-125620	05/15/1998	DENSO CORP		(Japan w/English Abstract)	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
<i>SPK</i>		Toshiyuki OHNO, "Recent Progress in SiC-Based Device Processing", Journal of Institute of Electronics, Information and Communication Engineers, pp. 128-133, Vol. J81-C-II, No. 1, January 1998, Japan					
EXAMINER <i>Shoanee Sla</i>			DATE CONSIDERED <i>3/26/05</i>				

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